

<b>Notice of References Cited</b>		Application No. <b>08/856,116</b>	Applicant(s) <b>Fusen Chen et al.</b>
		Examiner <b>Bernard Souw</b>	Group Art Unit <b>2814</b>

**U.S. PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,308,793	05/03/94	Taguchi et al.	438	642
B	5,354,712	10/11/94	Ho et al.	438	643
C	5,178,739	01/12/93	Barnes et al.	204	192.12
D					
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**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

**NON-PATENT DOCUMENTS**

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
u	R.F. Bunshah, "Handbook of Deposition Technologies for Films and Coatings", 2nd. Ed., Noyes Publications, NJ-NY, 1994	1994
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w		
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